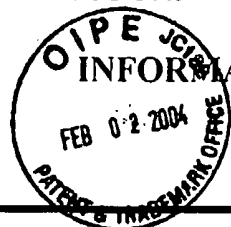


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Attorney Docket No.

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Kohl, et al.

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October 16, 2003

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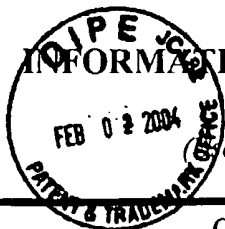
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